



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): A. Smith et al.

Serial No.: 10/775,718

Filed: February 9, 2004

Cust. No.: 33123

For: **METHOD AND APPARATUS FOR  
SELF-REFERENCED WAFER STAGE  
POSITIONAL ERROR MAPPING**

Examiner: K. Koyama

### CERTIFICATE OF MAILING PURSUANT TO 37 CFR 1.8

I hereby certify that this correspondence and the attached papers are being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

9/15/05  
Date

Michelle Melander  
Signature

### RESPONSE TO OFFICE ACTION AND REQUEST FOR RECONSIDERATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 15, 2005 in connection with the above-identified application, Applicant requests entry of this response and reconsideration of the application.

Amendments to the claims are reflected in the listing of claims, which begins on Page 2 of this document.

Remarks begin on Page 5 of this document

Replacement sheets for the drawings are presented in "Replacement Drawings Sheets" accompanying this request for reconsideration.